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***Nanoengineering: Fabrication,
Properties, Optics, Thin Films,
and Devices XIX***

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Contents

v *Conference Committee*

NANOSTRUCTURED THIN FILMS I

- 12202 02 **Understanding methods to determine energy levels of quantum dot films for device integration** [12202-1]
- 12202 03 **Layer by layer thin film fabrication with in-process laser patterning** [12202-2]
- 12202 04 **Oxygen mediated optical and electrical property modification of RF sputtered Ga₂O₃ thin films for photodetector application** [12202-5]
- 12202 05 **Reduction of oxygen vacancy related defects in RF sputtered deposited ZnO films by impurity (phosphorus) incorporation** [12202-6]

NANOSTRUCTURED THIN FILMS II

- 12202 06 **Laser conditioning effect for all-silica mirrors** [12202-10]
- 12202 07 **Direct color printing on Ag:TiO₂ thin films induced by nanosecond laser pulses** [12202-11]

NANOPHOTONIC STRUCTURES AND DEVICES

- 12202 08 **Control of in-plane light scattering using surface lattice resonances** [12202-13]

LIGHT-MATTER INTERACTION

- 12202 09 **Simultaneous confinement of acoustic phonons and near infrared photons in GaAs/AIAs multilayers by band inversion** [12202-24]

POSTER SESSION

- 12202 0A **Laser-induced Si nanoparticles and the application of RGB resonance color-filters** [12202-32]
- 12202 0B **Polymer coatings with rare-earth activated phosphors for optical fiber fluorosensors** [12202-34]

- 12202 0C **A method for modifying the surface properties of ZnO nanowires deposited as thin films on various substrates** [12202-40]
- 12202 0E **Optimization of substrate to culture and image live cells for surface plasmon microscopy** [12202-43]
- 12202 0F **Nanoengineering instrumentation to control the optical properties of plasmonic nanoparticles for thin film optics** [12202-36]